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C
5/19/01
VS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/512,968
Filing Date February 24, 2000
Inventor David R. Hembree
Assignee Micron Technology, Inc.
Group Art Unit 2832
Examiner V. Nguyen
Attorney's Docket No. MI22-1363
Title: Wafer Processing Apparatuses and Electronic Device Workpiece
Processing Apparatuses (As Amended)

RESPONSE TO JANUARY 29, 2001 OFFICE ACTION

To: Assistant Commissioner for Patents
Washington, D.C. 20231

From: James D. Shaurette (Tel. 509-624-4276; Fax 509-838-3424)
Wells, St. John, Roberts, Gregory & Matkin P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

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Sir:

Responsive to the Office Action dated January 31, 2001, Applicant
amends and remarks as follows:

05/04/2001 SHINASS1 00000019 09512968

01 FC:103 90.00 OP
02 FC:102 640.00 OP

AMENDMENTS

In the Title

Please replace the title with the following: --WAFER PROCESSING
APPARATUSES AND ELECTRONIC DEVICE WORKPIECE PROCESSING
APPARATUSES--.